

ePIC SVT configuration for eRD104/111/113 work

N. Apadula, G. Contin, G. Deptuch, D. Elia, L. Gonella, P. Jones, I.
Sedgwick, E. Sichterman

EIC SC general meeting – 7 November 2022

EIC SC work for FY23

- The work of the EIC SC for the development of the EPIC silicon vertex and tracking (SVT) detector proceeds within the eRD104, eRD111, eRD113 projects.
- The combined aim of eRD104/111/113 for FY23 is to
 - Be ready to **design the LAS sensor** in FY24.
 - Reach a **mature conceptual design** of all items of the EPIC SVT (supported by prototyping/testing of components).
 - Full details in the proposals at <https://wiki.bnl.gov/conferences/index.php/ProjectRandDFY23>
- **Work needs to start work towards these goals.** Clearly, there **still many open points and unknowns**, but we need to start working on technical details and engineering aspects that will feed back important information to evolve the design.
- Let's discuss a starting point today → **ePIC SVT configuration v0.0**

Current status: ePIC SVT layout

- EPIC SVT layout developed for the first simulation campaign

5 barrel layers, 5 disks per side

See Ernst's talk at <https://indico.bnl.gov/event/17418/>

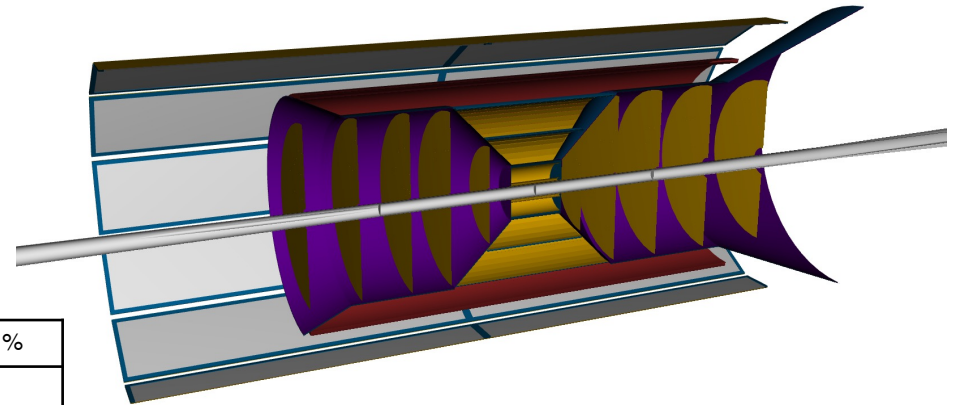
Current implementation in DD4Hep in Shujie's talk at <https://indico.bnl.gov/event/17394/>

This design includes **only Si active area and simplified description of support structures and services** → Engineering details need to be worked out and added, see Nikki's talk next.

Also, we are still using **truth seeding** and have **no background embedded in simulations**, so this layout might still change.

BARREL	r [mm]	l [mm]	X/X0 %
Layer 0	36	270	0.05
Layer 1	48	270	0.05
Layer 2	120	270	0.05
Layer 3	270	540	0.25
Layer 4	420	840	0.55

DISKS	+z [mm]	-z [mm]	X/X0 %
Disk 1	250	-250	0.24
Disk 2	450	-450	0.24
Disk 3	700	-650	0.24
Disk 4	1000	-900	0.24
Disk 5	1350	-1150	0.24



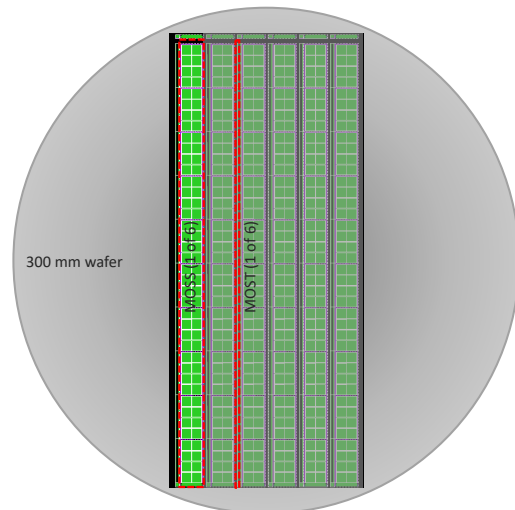
Current status: Sensor technology

- 65 m technology validation almost completed with testing of MLR1 structures → no show stopper.
- ER1 submission of first, wafer-scale sensor by end of the year. Scope: learning about stitching and yield of large area sensor.

Expect to know yield in about 9 months to one year from now.

- Reticule size not yet fixed, current assumption to progress our work on LAS and conceptual designs 18.85 mm x 30 mm.

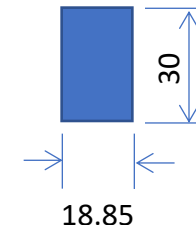
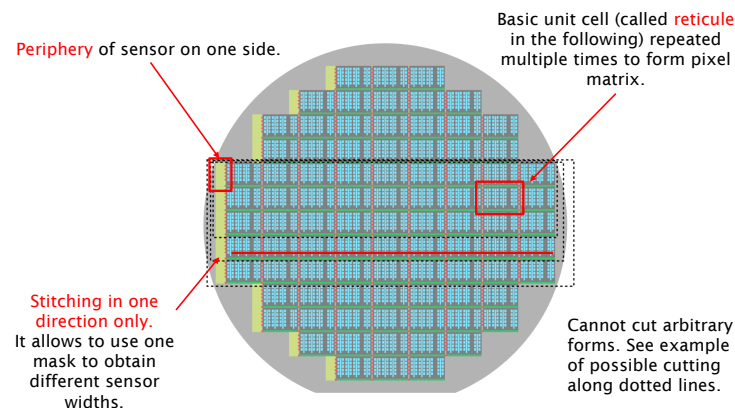
Expect to know final reticule size at ITS3 ER2, currently scheduled for Q1 24.



Stitching for ITS3 sensor

- Stitching deployed to design a wafer scale sensor.

Example of stitched wafer layout.



Layout Studies

- EIC Vertex Layers

 - Use ITS3 curved wafer-scale stitched sensors

 - Three layers (L0, L1, L2); Radii = 36 mm, 48 mm and 120 mm (see note below)

- EIC Sagitta Layers

 - Baseline is smaller format stitched sensors (EIC LAS) on staves

 - Two layers (L3, L4); Radii = 270 mm and 420 mm

- EIC Disks

 - Several sensor variants (different sizes) needed for improved yield and tiling flexibility

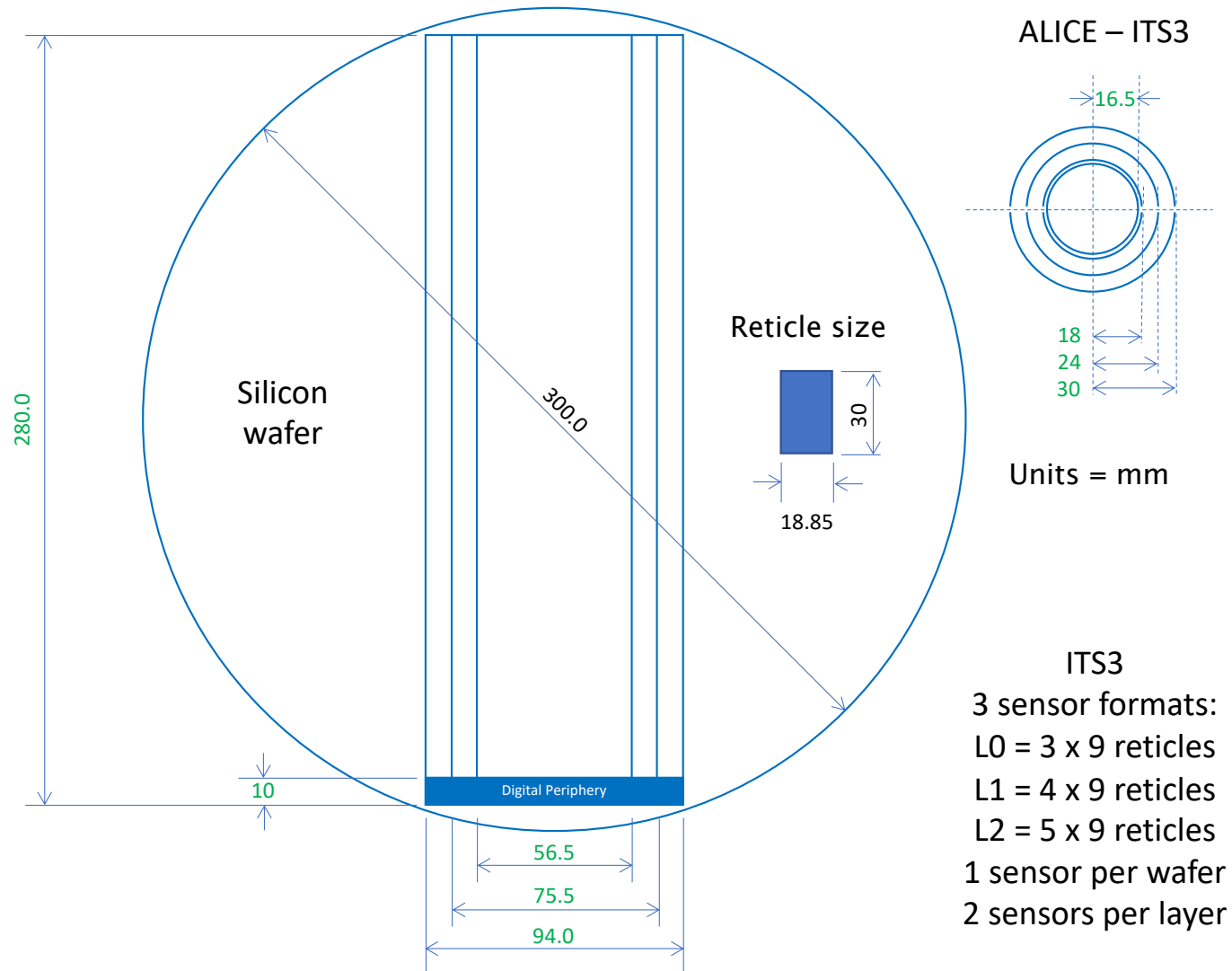
 - Requires changes to stitching plan & periphery

 - Studying optimum tiling geometry

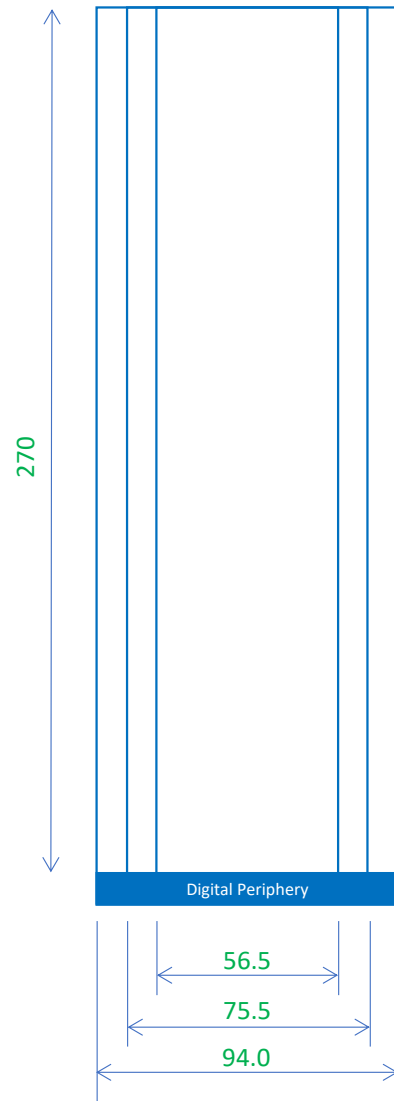
- What follows is based on studies done by Peter Jones

Note: beryllium beampipe outer radius = 31.75 mm
Require spacing of 5 mm to first vertex layer for beam pipe bakeout

ALICE ITS3 Sensor Layout

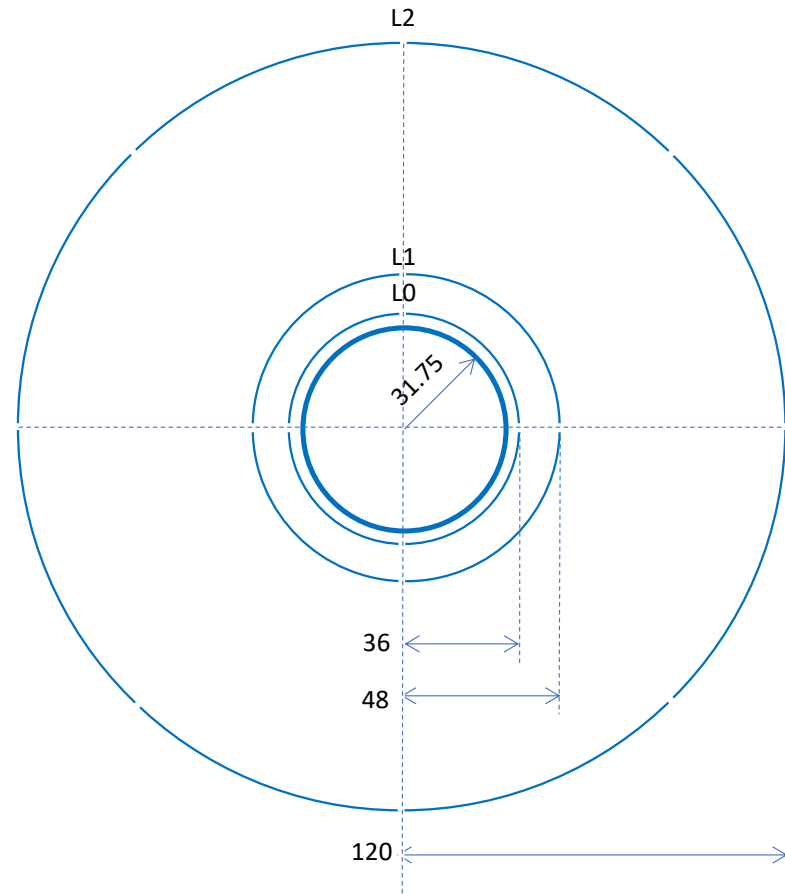
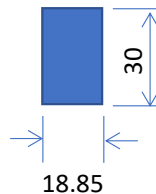


EPIC Vertex Layers



L0 = 4 x 56.5; R = 36
L1 = 4 x 75.5; R = 48
L2 = 8 x 94.0; R = 120

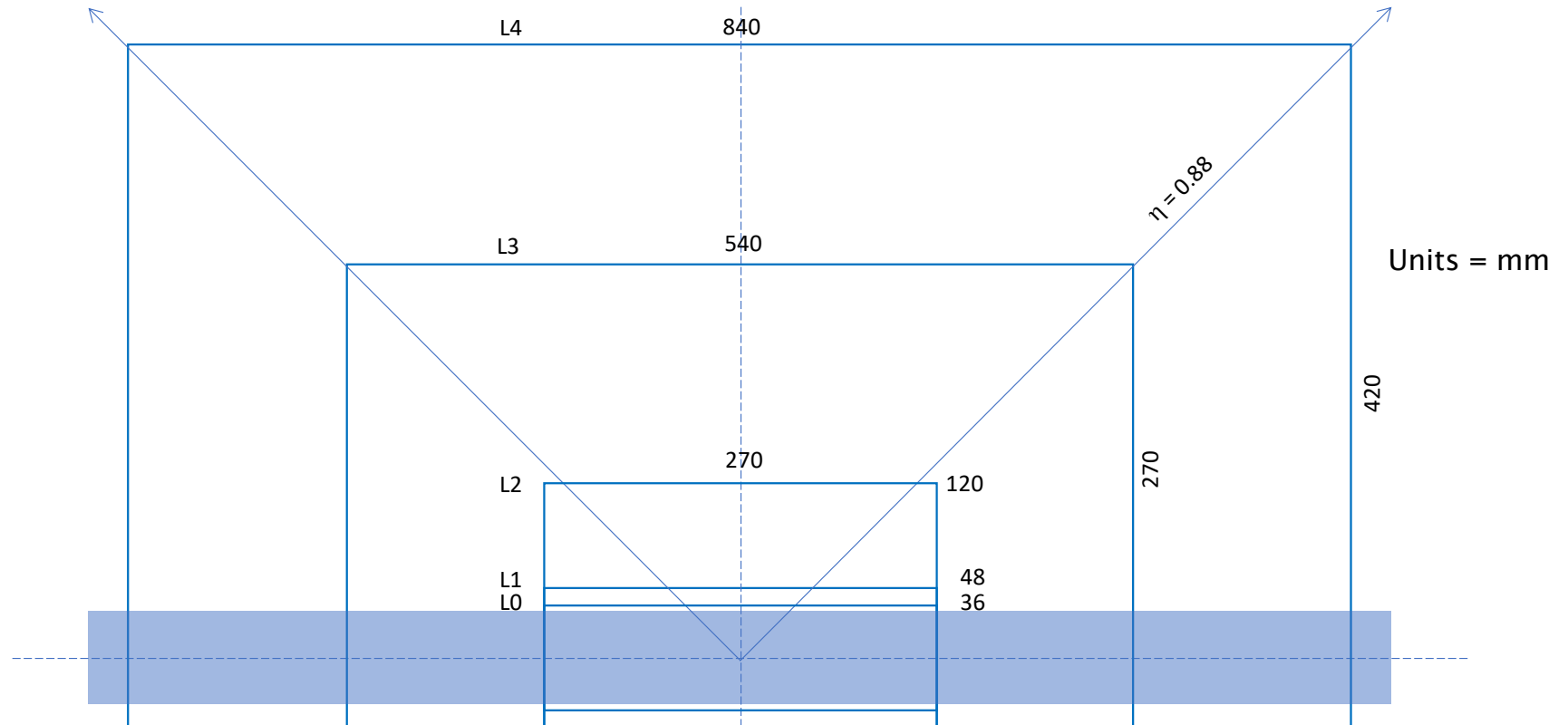
ePIC - SVT
Same 3 sensor formats:
L0 = 3 x 9 reticles
L1 = 4 x 9 reticles
L2 = 5 x 9 reticles
1 sensor per wafer
4 or 8 sensors per layer



Units = mm

EPIC Vertex and Sagitta Layers

Note: these are active lengths; they do not include the periphery

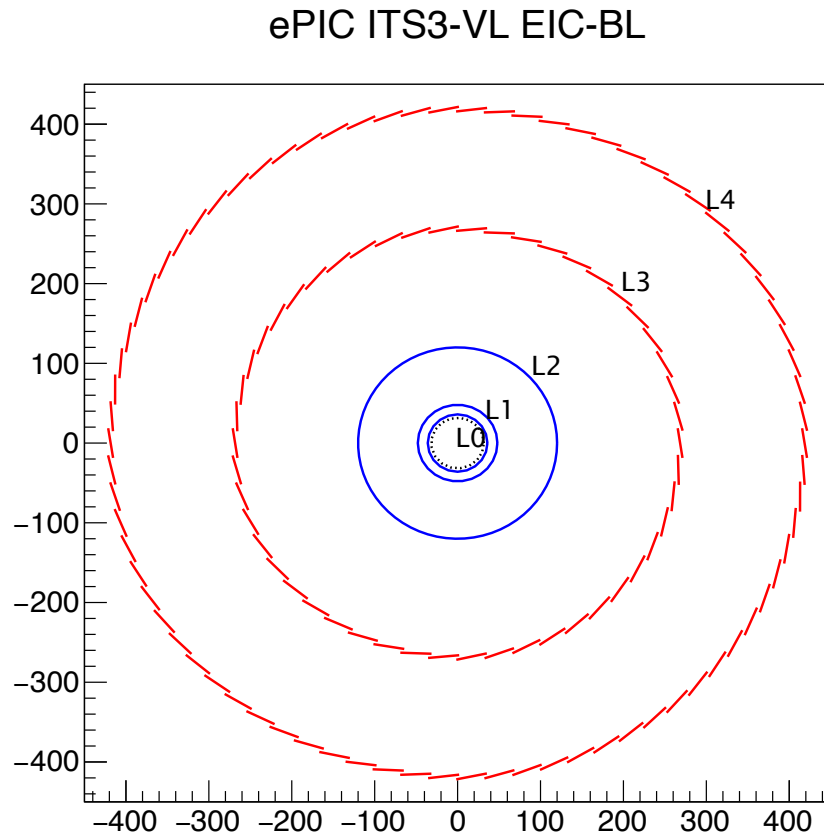


L0, L1 and L2 lengths are **single** sensors that are **270 mm** long (9 reticles)

L3 length can be achieved using **two** sensors **270 mm** long (9 reticles), or **three** sensors **180 mm** long (6 reticles)
Choice of two or three sensors may be decided by sensor yield

L4 length can be achieved using **four** sensors **210 mm** long (7 reticles)

EPIC Sagitta Layers



- Sagitta Layers

Default design consists of ITS2-like staves

- L3

50 staves, $2 \times 18.85 = 37.7$ mm wide

Mean radius = 268.4 mm

$R\phi$ overlap = 3.5 mm $\sim 10\%$

$2 \times 2 = 4$ or $2 \times 3 = 6$ sensors per staffe

Require 200 1×9 sensors or 300 1×6 sensors

- L4

78 staves, $2 \times 18.85 = 37.7$ mm wide

Mean radius = 418.5 mm

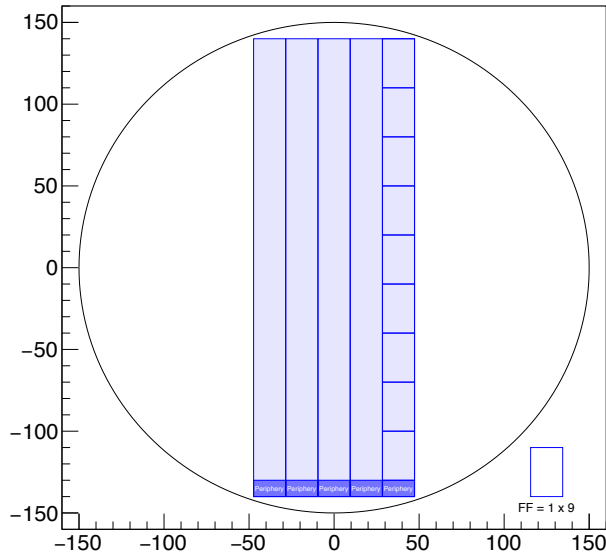
$R\phi$ overlap = 3.5 mm $\sim 10\%$

$2 \times 4 = 8$ sensors per staffe

Require 624 1×7 sensors

Wafer Usage – Sagitta Layers

EIC-LAS



L3 Option 1

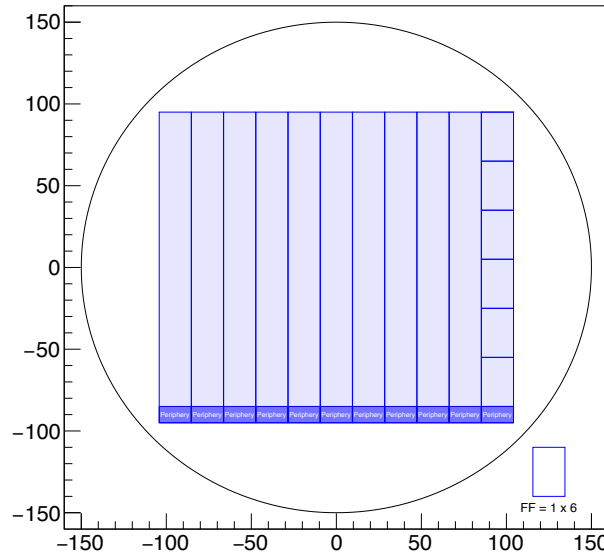
1 x 9 sensors

5 sensors per wafer

45 reticles per wafer

200 sensors (40 wafers)

EIC-LAS



L3 Option 2

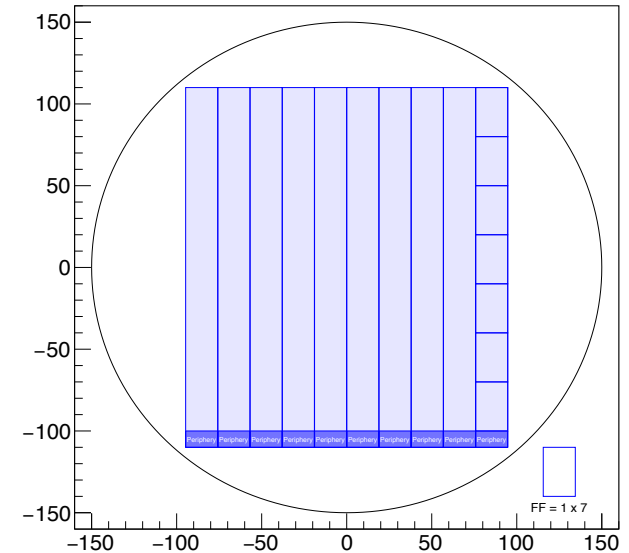
1 x 6 sensors

11 sensors per wafer

66 reticles per wafer

300 sensors (28 wafers)

EIC-LAS



L4 Option 1

1 x 7 sensors

10 sensors per wafer

70 reticles per wafer

624 sensors (63 wafers)

Higher cost, lower material

Use as default.

Lower cost
Higher material

Note #1: 100 micron dicing lanes between each sensor assumed

Note #2: if using 2 x 9 or 2 x 6 sensors, both L3 options will require more wafers;
[module concept needed](#) (one module made of two 1x9/1x7 sensors for L3/L4)

Summary – Barrel v0.0

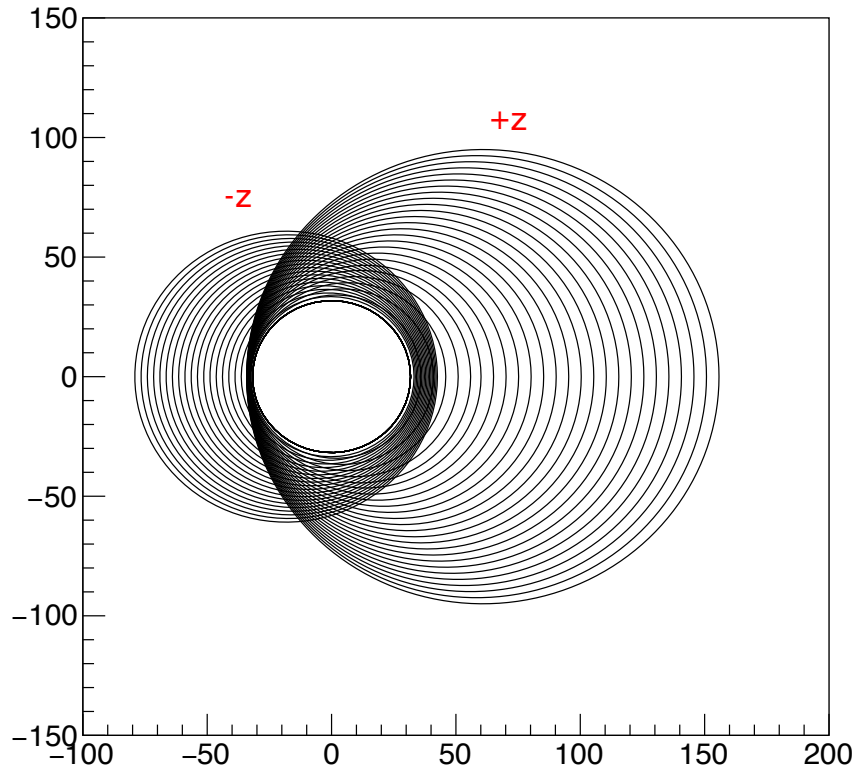
Note: these are active lengths; they do not include the periphery

Layers	Reticules	Sensor width x length [mm ²]	Layer length [mm]	Layer radius [mm]	Number of sensors per layer	Number of staves
L0	3 x 9	56.55 x 270	270	36	4	NA
L1	4 x 9	75.4 x 270	270	48	4	NA
L2	5 x 9	94.25 x 270	270	120	8	NA
L3	1 x 9	18.85 x 270	540	268.4	200	50
L4	1 x 7	37.7 x 210	840	418.5	624	78

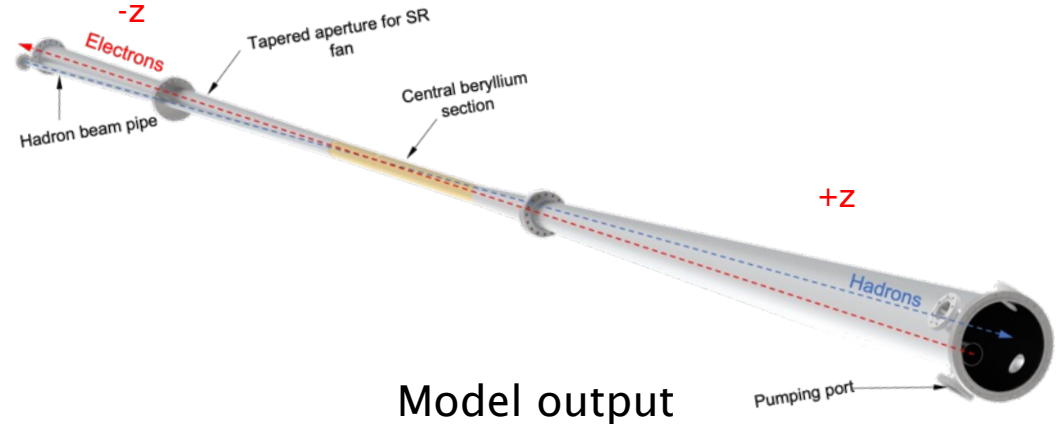
Forward and Backward Disks

■ Beam pipe model

EIC Beampipe



Beampipe profile; 100 mm steps



Model output

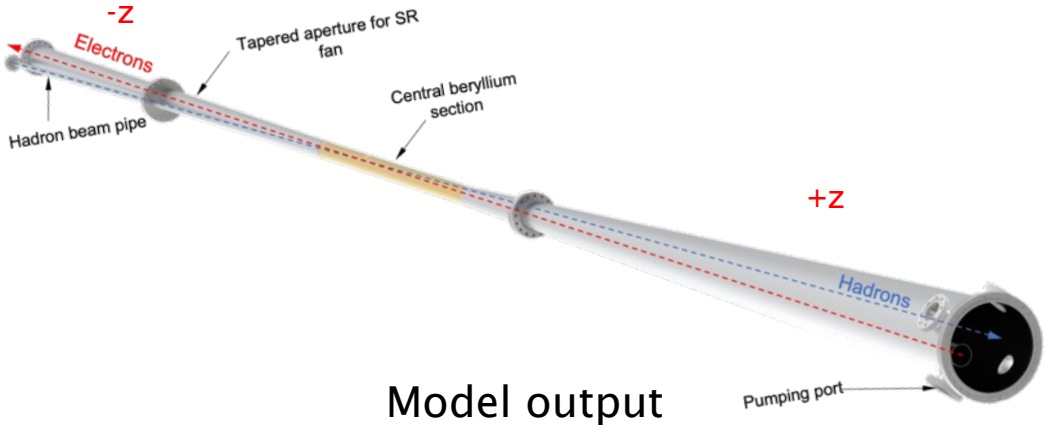
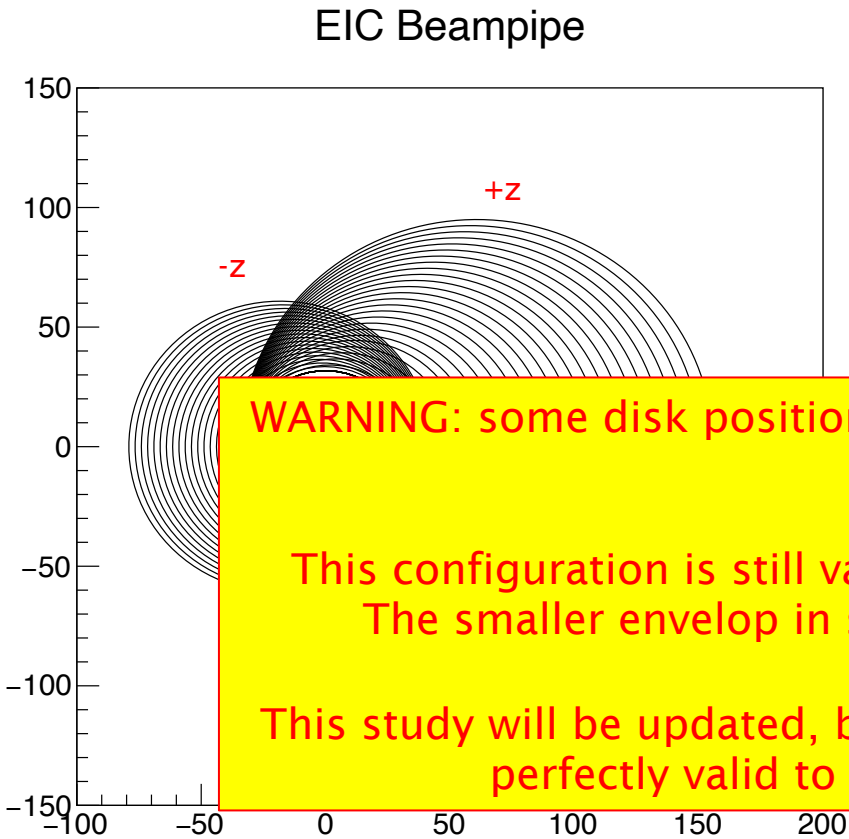
The beam pipe radius has been modelled as a function of z from the original CAD drawings

	Z - ePIC	R_bpip	x_offset	R_inner	R_outer
5n	-1350	41.08	-5.30	46.1	430
4n	-1000	35.76	-1.81	40.8	430
3n	-700	31.76	0.00	36.8	430
2n	-450	31.76	0.00	36.8	430
1n	-250	31.76	0.00	36.8	230
1p	250	31.76	0.00	36.8	230
2p	450	31.76	0.00	36.8	430
3p	700	32.86	0.56	37.9	430
4p	1000	40.58	7.85	45.6	430
5p	1350	49.12	16.02	54.2	430

Dimensions are mm

Forward and Backward Disks

- Beam pipe model



Model output

The beam pipe radius has been modelled as a

WARNING: some disk positions (3n/4n/5n) have changed since this work was done.

This configuration is still valid if the mRICH is used in the BW region. The smaller envelop in slide 3 is needed if the pfRICH is used.

This study will be updated, but in the meantime these positions are still perfectly valid to kick-off the engineering studies.

					R_outer
					430
					430
					430
					430
					230
					230
					430
3p	700	32.86	0.56	37.9	430
4p	1000	40.58	7.85	45.6	430
5p	1350	49.12	16.02	54.2	430

Dimensions are mm

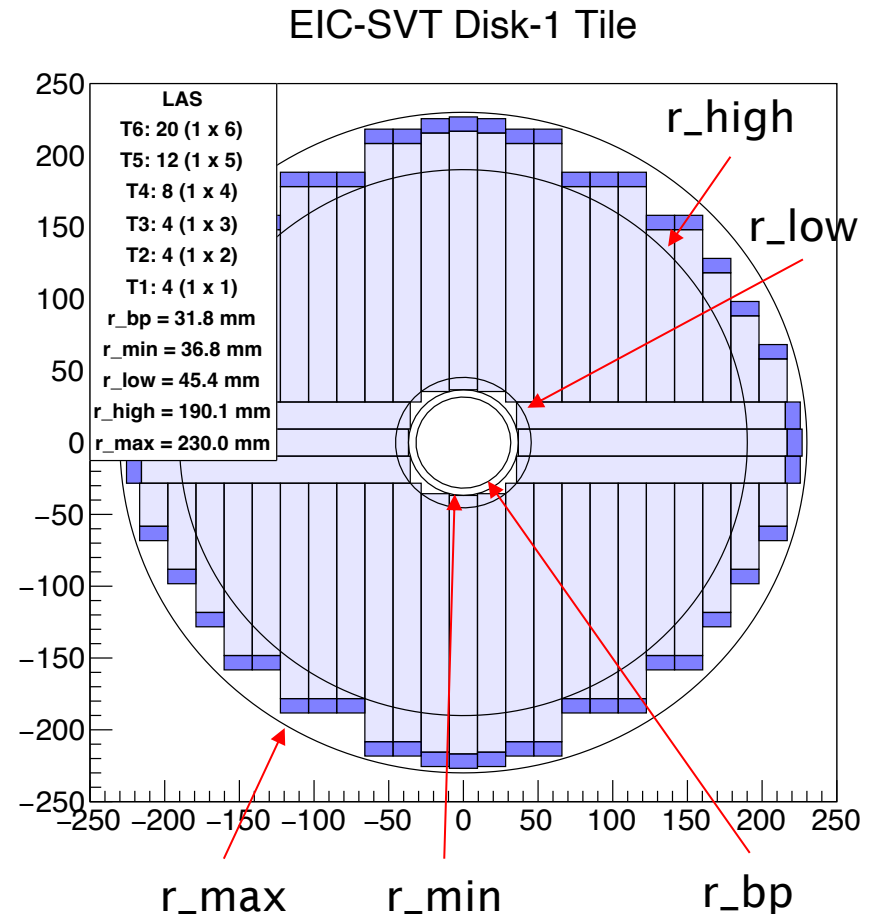
Disk Tiling

- More details on the disks tiling study and methods in the backup and here <https://indico.bnl.gov/event/17073/>

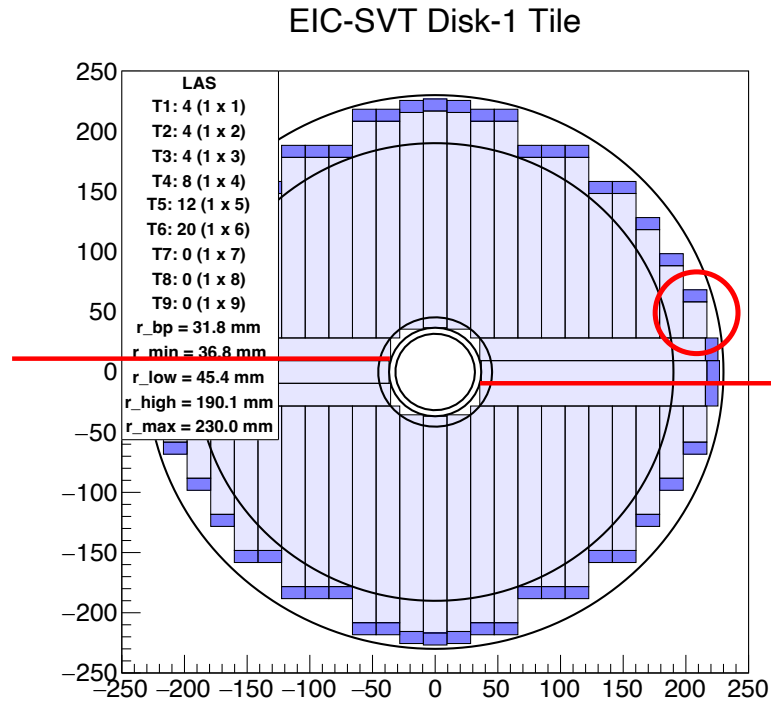
r_{bp} = beam pipe radius
 $r_{min} = r_{bp} + 5 \text{ mm}$
 r_{max} = outer disk radius
 r_{low} = smallest radius with full acceptance
 r_{high} = largest radius with full acceptance

TX: YY (1x X) → on the disk there are YY Tiles made of one stitched row of X reticules.

Example: T5: 12 (1x5) → on the disk there are 12 tiles made of one stitched row of 5 reticules (i.e. 18.85 mm x 150 mm).

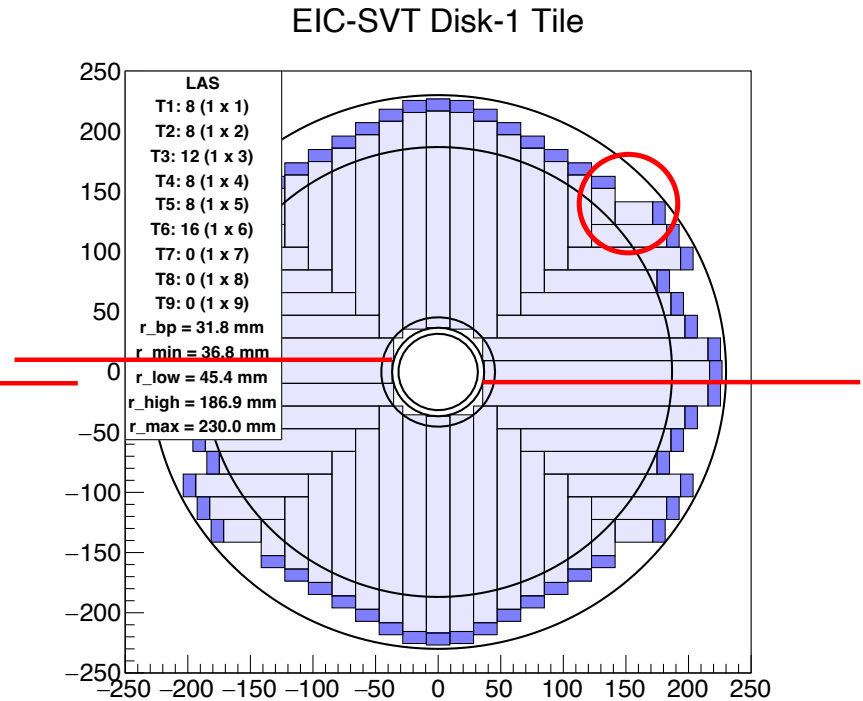


Disk 1 – Tiling Options



52 sensors
236 reticles

Fewer connections
More coverage



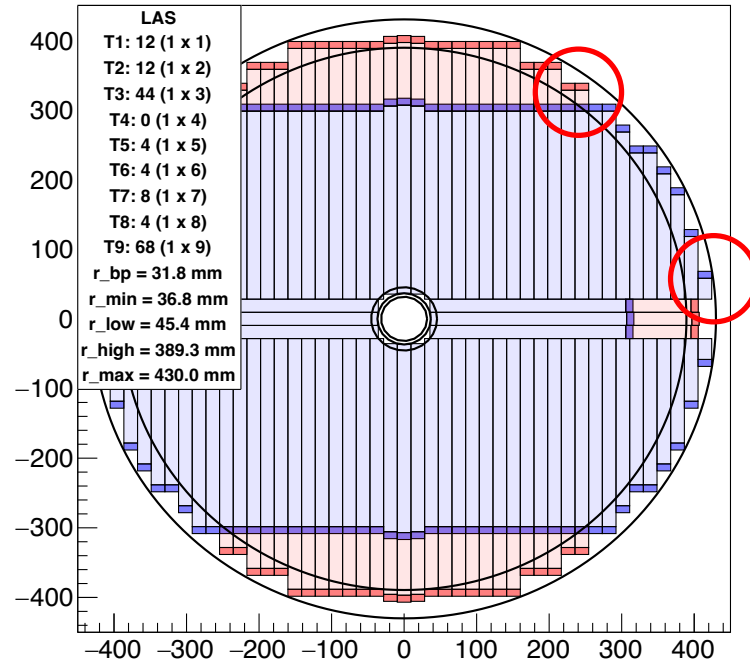
60 sensors
228 reticles

Note #1: no restriction on sensor variants but disk size imposes its own constraint

Note #2: lines indicate possible division of disk into two halves for assembly around the beam pipe

Disk 2/3n – Tiling Options

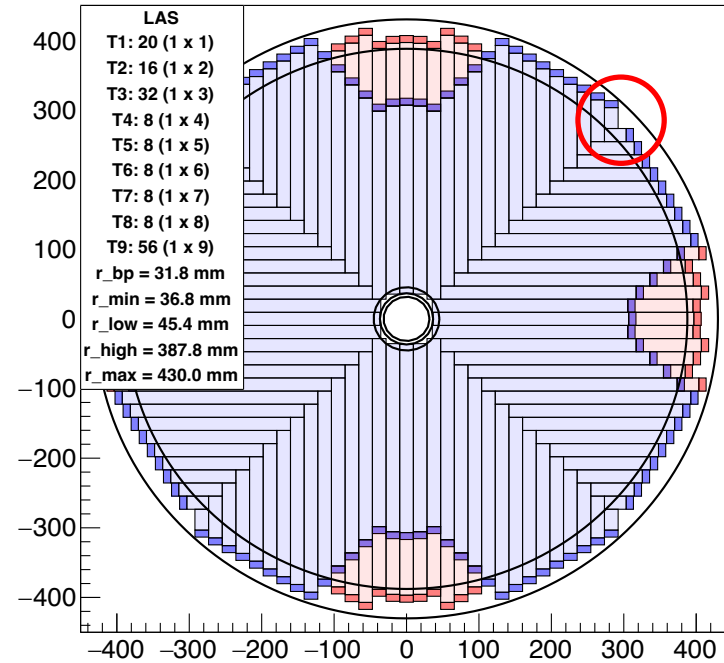
EIC-SVT Disk-2/3n Tile



156 sensors
912 reticles

Fewer connections
More coverage

EIC-SVT Disk-2/3n Tile



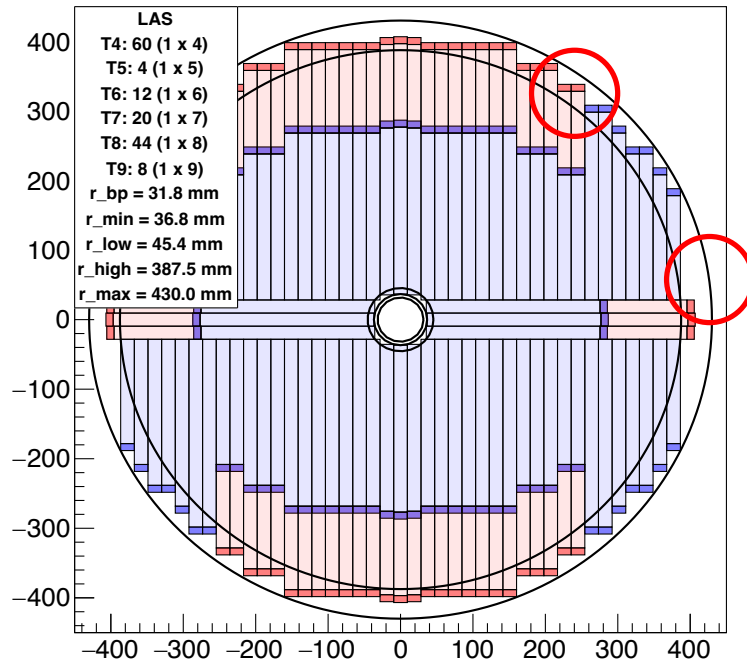
164 sensors
892 reticles

Note #1: no restriction on sensor variants

Note #2: Sensors in red on reverse side of disk overlap digital periphery of inner sensors in blue

Disk 2/3n – Restricting Sensor Size

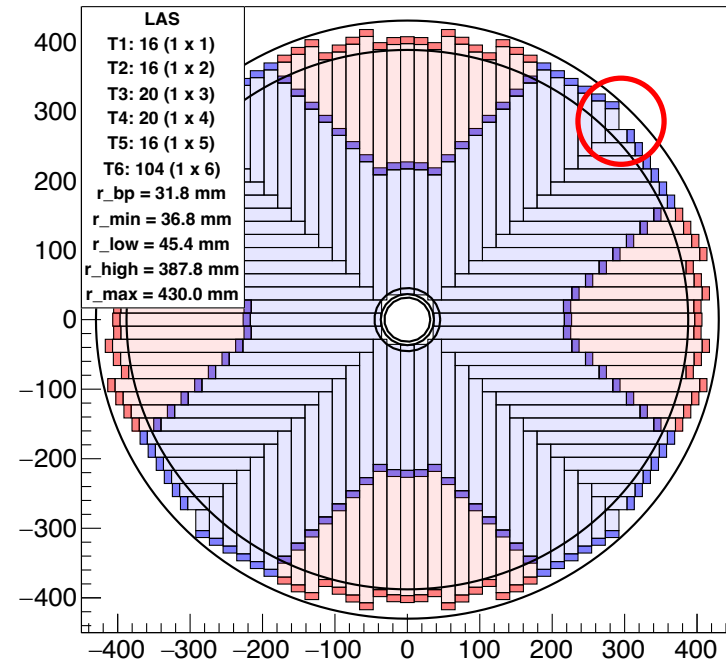
EIC-SVT Disk-2/3n Tile



148 sensors
896 reticles

Fewer, longer sensors T4 – T9

EIC-SVT Disk-2/3n Tile



192 sensors
892 reticles

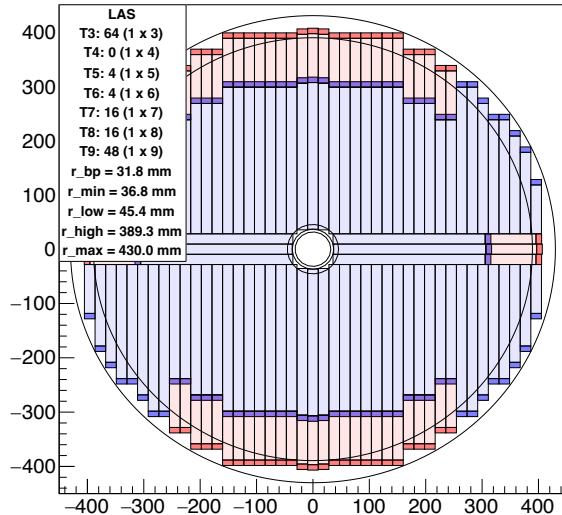
More, shorter sensors T1 – T6

Use picket fence design as default for all disks.

Disk2/3n – Varying Restriction on Sensor Size

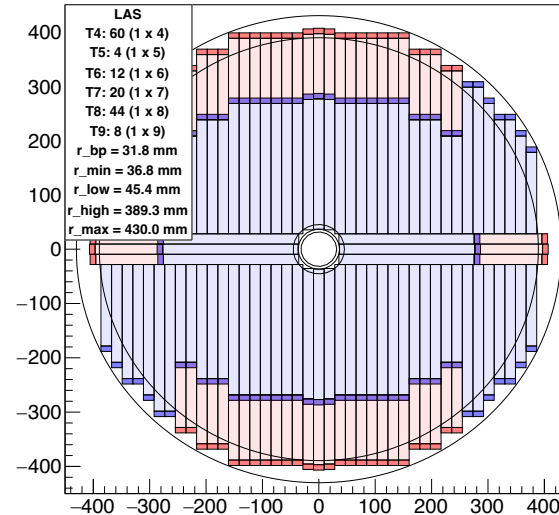
EIC-SVT Disk-2/3n Tile

T3 – T9



EIC-SVT Disk-2/3n Tile

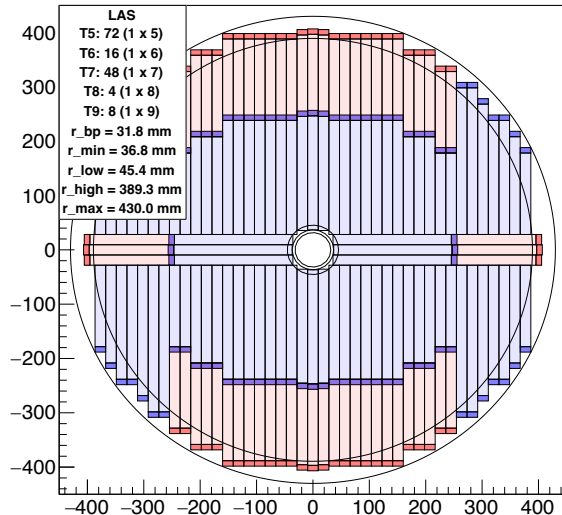
T4 – T9



Use T4 – T9 as default for disks 2 to 5.

EIC-SVT Disk-2/3n Tile

T5 – T9



Greater prospect of reducing number of sensor types with the simple tiling design

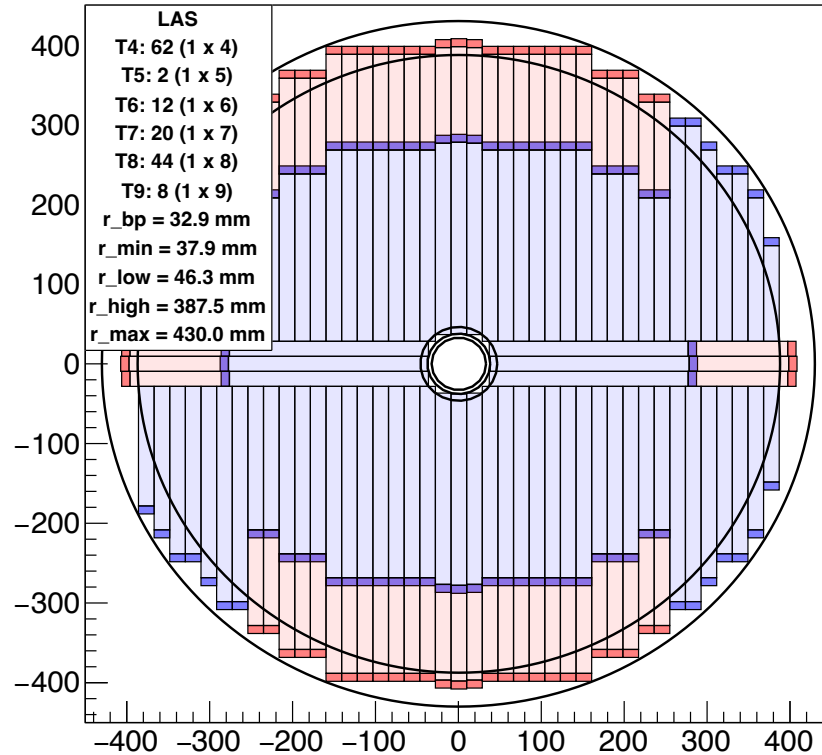
However, the reduction in sensor types pushes periphery inwards, adding material due to flex cables running over the outer sensors at larger radii

Note: shorter variants produce more sensors per wafer

Disk 3p

Note: disk center offset from $x = 0$ to accommodate beam pipe fan out

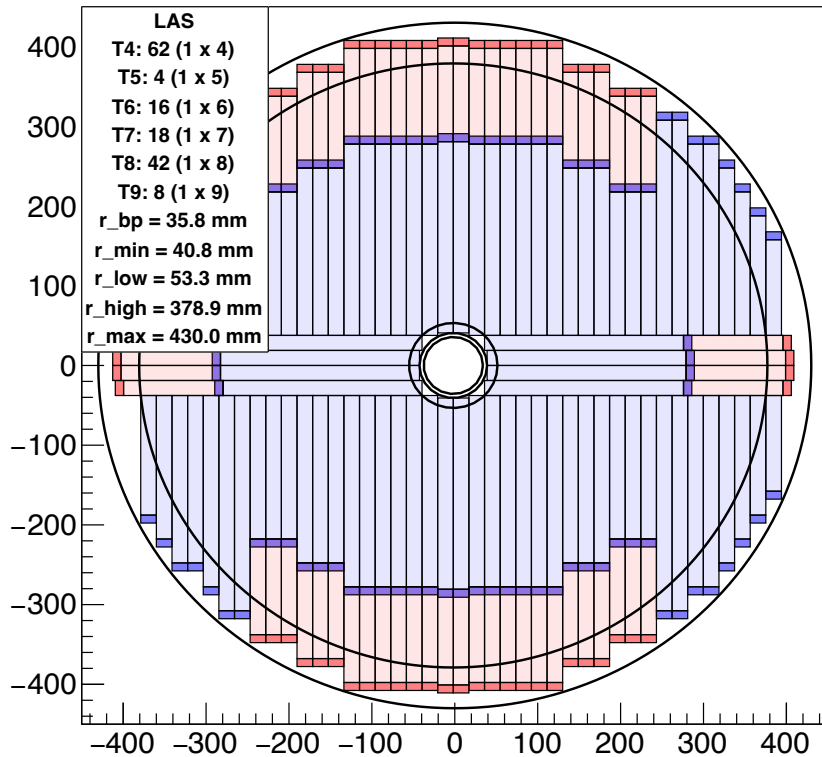
EIC-SVT Disk-3p Tile



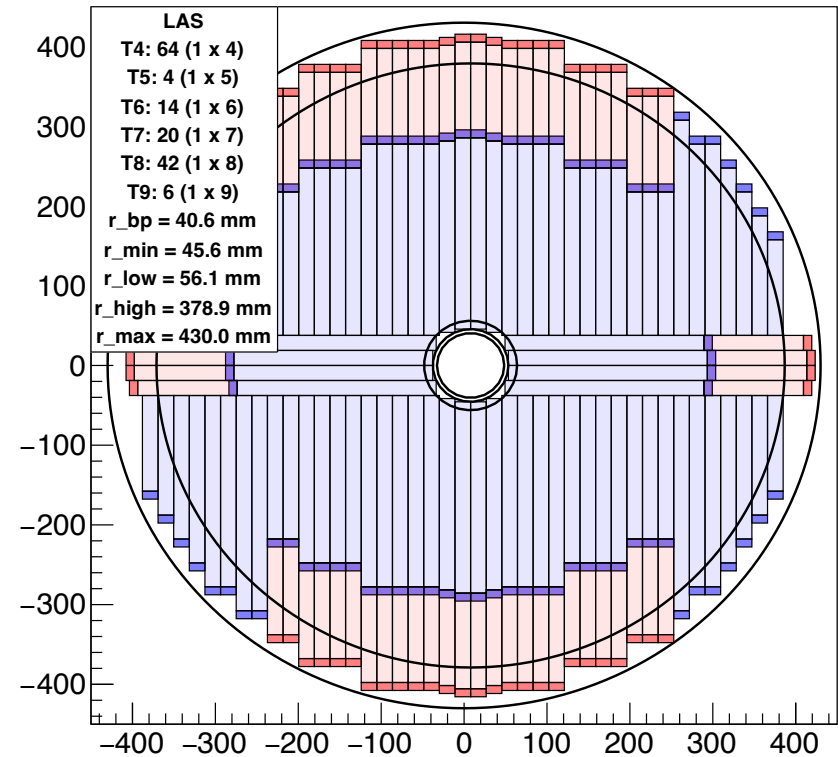
Disk $4n/p$

Note: disk center offset from $x = 0$ to accommodate beam pipe fan out

EIC-SVT Disk-4n Tile



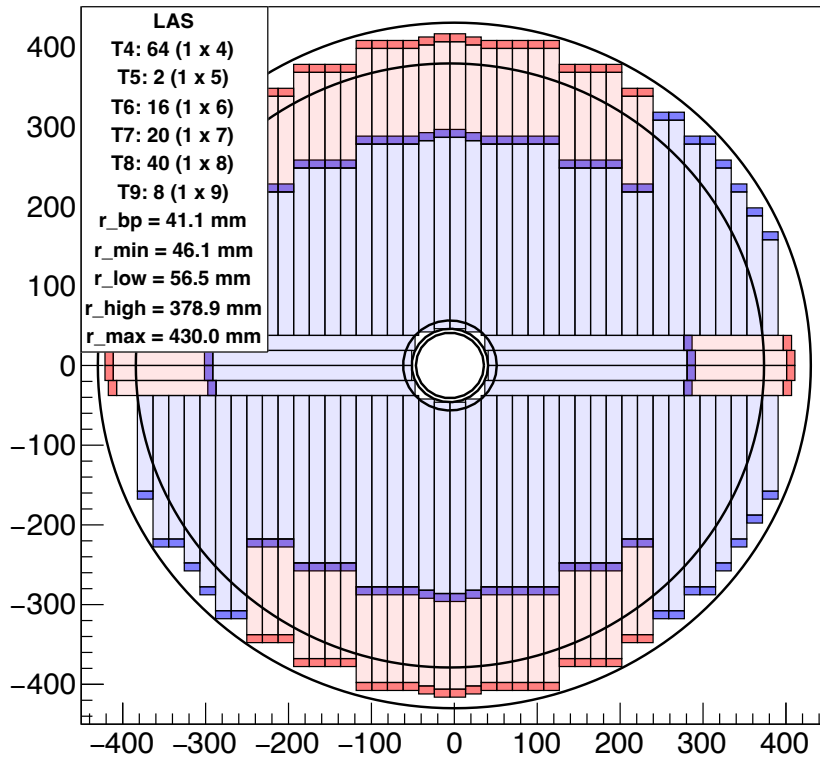
EIC-SVT Disk-4p Tile



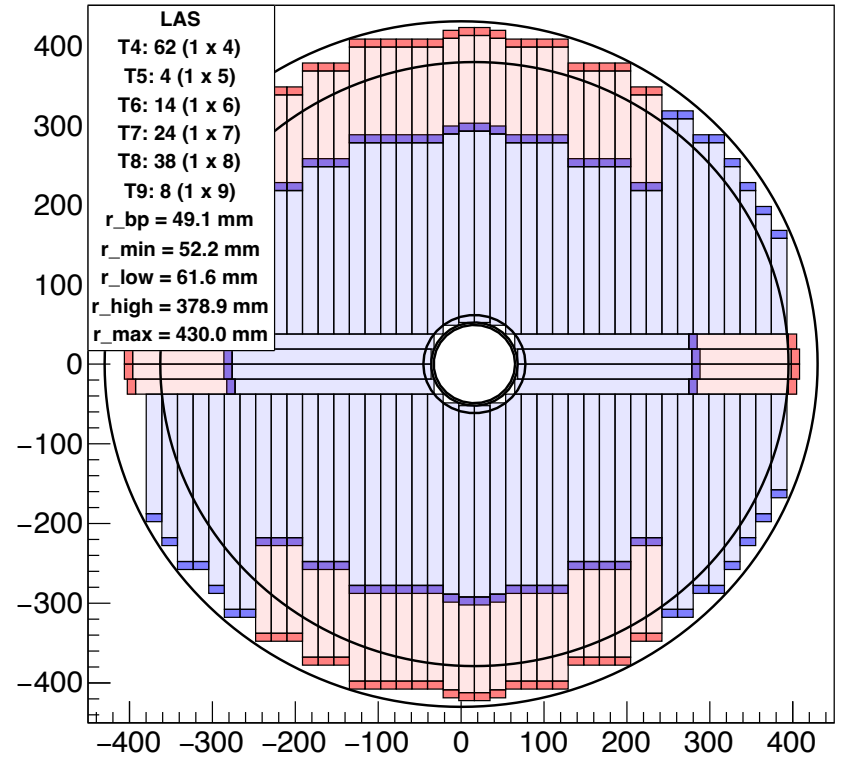
Disk 5n/p

Note: disk center offset from $x = 0$ to accommodate beam pipe fan out

EIC-SVT Disk-5n Tile



EIC-SVT Disk-5p Tile



Summary – Disks v0.0

BACKWARD									
	T1	T2	T3	T4	T5	T6	T7	T8	T9
Disk 1	4	4	4	8	12	20	0	0	0
Disk 2	0	0	0	60	4	12	20	44	8
Disk 3	0	0	0	60	4	12	20	44	8
Disk 4	0	0	0	62	4	16	18	42	8
Disk 5	0	0	0	64	2	16	20	40	8
FORWARD									
	T1	T2	T3	T4	T5	T6	T7	T8	T9
Disk 1	4	4	4	8	12	20	0	0	0
Disk 2	0	0	0	60	4	12	20	44	8
Disk 3	0	0	0	62	2	12	20	44	8
Disk 4	0	0	0	64	4	14	20	42	6
Disk 5	0	0	0	62	4	14	24	38	8

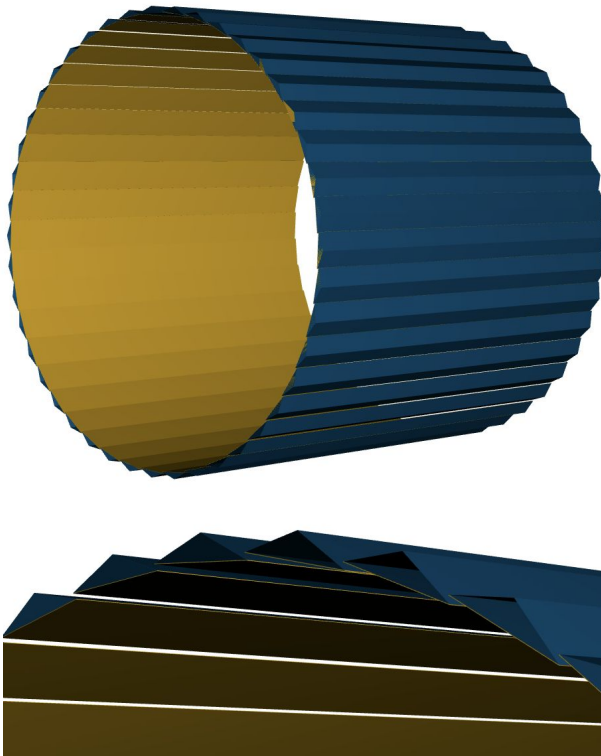
Mechanical Design as Implemented in DD4HEP

- Basic model for sagitta layers

44 tilted triangular staves (not 50 or 78)

Silicon + Al + carbon fiber plates

No truss structure; cooling pipes, etc.



- Support cone design issues

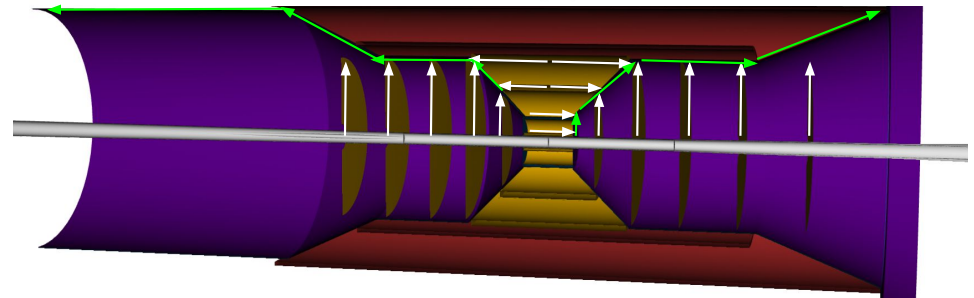
Routing of cables to/from first two vertex layers is assumed to be radially outwards

Implies a 90-degree bend in the FPC

No location identified for the patch panel needed to connect FPC to external cables

Length of vertex and sagitta layers does not include periphery or FPC

Radius of last disk is smaller than the radius of the support cone



Figures from Shujie Li (LBNL)

More engineering challenges discussed in Nikki's talk.

Summary

▪ Vertex Layers (L0, L1, L2)

Will use ITS3 wafer-scale sensors

L2 now at $R = 120 \text{ mm}$

$R1 - R0 = 12 \text{ mm}$

$R2 - R1 = 72 \text{ mm}$

For ITS3 the layer spacing is 6 mm

Requires new mechanical design

▪ Sagitta Layers (L3, L4)

L3 length (540 mm) can be made with 2 sensors of length 270 mm (9 reticles)

L3 could also be made with 3 sensors of length 180 mm (6 reticles) to improve wafer usage

Second option requires services running over the stave; also cooling for the periphery → First option as default for now

L4 length (840 mm) can be made with 4 sensors of length 210 mm (7 reticles)

Same comment about services and cooling

Module concepts needed for L3 and L4

▪ Tiling of disks

Method to tile the disks developed

Vertical tiles (design #1) are preferred

Fewer sensors providing greater coverage

Studies of restricted sensor sizes on-going

Need to convert this into estimate for the number of wafers needed (with inputs from designers)

▪ Mechanical Design

Need to investigate an ITS2-like stave option for the sagitta layers

Need to address cable routing, cooling and compatibility with EPIC support cone

No conceptual design the disks; not clear that air cooling will work here

Conclusion

- The proposed configuration is based on

The ePIC SVT configuration for the first simulation campaign (Oct/Nov 2022).

A reticule size of 18.85 mm x 30 mm.

An exercise of how to best tile staves and disks using 1. and 2.

- This starting point is not yet informed by

Sensor yield (i.e. stitched rows of 9 reticules might not be possible) → biggest unknown!

Engineering aspects of staves/disks, mechanics, cooling, integration, etc.

Designers input on LAS.

...

Let's use this configuration as starting point to work on some of these missing inputs and iterate on the SVT design with more information.

Backup

Disk Tiling Study

▪ Aim of the study

Investigate sensor (LAS) formats needed

Try to restrict the number of variants

Try to keep periphery to outer radius of disk

▪ Tiling strategy

Two designs starting with a central cross

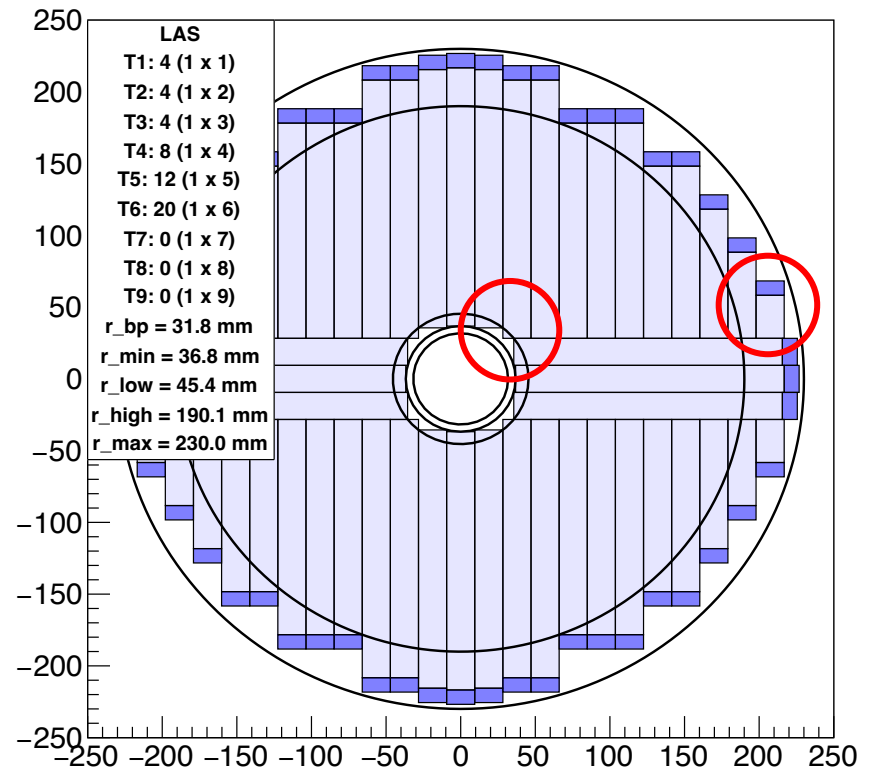
Design #1 = vertical tiles/sensors (shown)

Design #2 = herringbone pattern (alternating vertical and horizontal tiles)

No sensor overlap on same side of disk

Sensor variants are assumed to be 1 reticle width by up to 9 reticle lengths

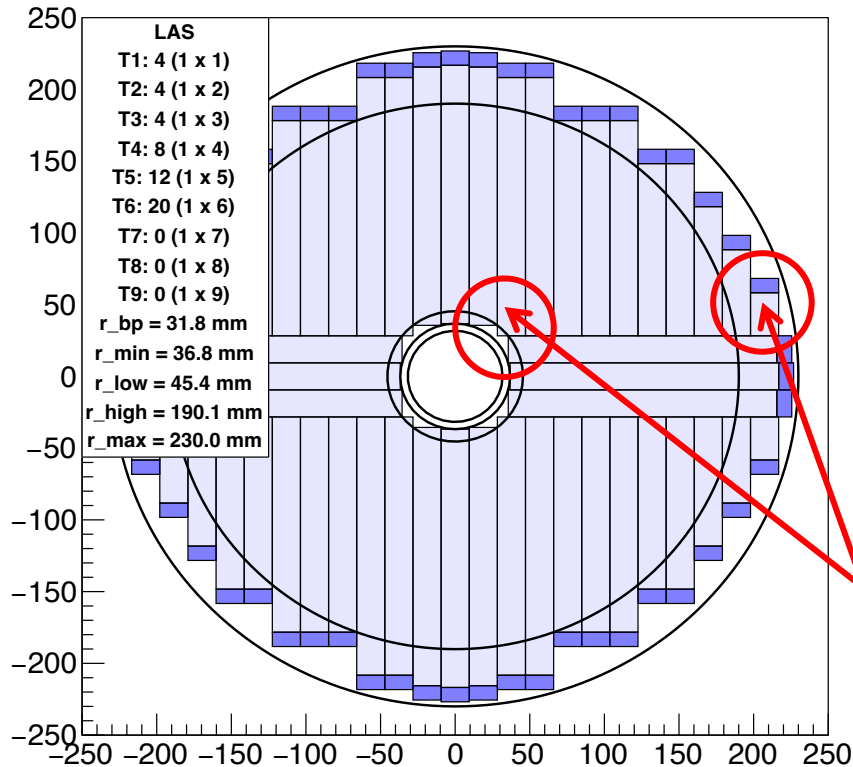
EIC-SVT Disk-1 Tile



Example: Disk 1
z = +/- 250 mm

Disk Tiling Algorithm

EIC-SVT Disk-1 Tile



$z = \pm 250 \text{ mm}$
Central cross = 3 sensors

The algorithm

- Try to keep periphery to larger radii
- Two designs, each based on a central cross pattern smaller than the inner diameter of the disk
- Design #1 = vertical tiles (shown)
- Design #2 = herringbone pattern (alternating vertical and horizontal tiles)
- The minimum disk radius (r_{min}) is 5 mm larger than the beam pipe radius (r_{bp}) for bake out
- Sensor and periphery must be contained within the min and max radii of the disk (r_{min} and r_{max}).
- For each disk, the algorithm calculates the smallest and largest radii with full acceptance (r_{low} and r_{high})
- The algorithm does not permit any sensor overlap
- Acceptance at small radii could be improved by allowing some sensor overlap; placing overlapping sensors on the reverse side of the disk (in progress)
- Limits on the max and min sensor length can be applied
- Study the number of sensor variants that are needed

Disk Tiling Method

